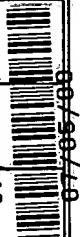


#6

LIST OF PUBLICATIONS CITED BY APPLICANT	<u>Attorney Docket No.</u> SEL 191	<u>Serial No.</u> Not Assigned
	<u>Applicant</u> Koichiro TANAKA et al	
	<u>Filing Date</u> Herewith	<u>Group</u>

JC542 U.S. PTO

09/610637



## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
DSM ↓	5,561,081	10/01/96	Takenouchi et al	437	174	02/03/94
	5,897,799	04/27/99	Yamazaki et al	219	121	06/11/96
	5,900,980	05/04/99	Yamazaki et al	359	619	02/06/97
	5,959,779	09/28/99	Yamazaki et al	359	624	03/04/98
	5,968,383	10/19/99	Yamazaki et al	219	121	10/23/97
	6,002,101	12/14/99	Yamazaki et al	219	121	10/23/97
	6,002,523	12/14/99	Tanaka	359	624	09/29/98
	6,038,075	03/14/00	Yamazaki et al	359	626	02/28/97

## FOREIGN PATENT DOCUMENTS

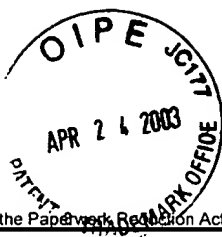
	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
DSM ↓	JP 11-097702	04/09/99	Semiconductor Energy Laboratory Co., Ltd.			09/19/97
	JP 11-133463	05/21/99	Semiconductor Energy Laboratory Co., Ltd.			10/31/97

## OTHER PUBLICATIONS

(Including Author, Title, Date, Pertinent Pages)

DSM	English abstract re Japanese Patent Application No. JP 11-097702, published April 9, 1999. English abstract re Japanese Patent Application No. JP 11-133463, published May 21, 1999.
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EXAMINER: <u>RLS</u>	DATE CONSIDERED: <u>7/25/03</u>
<p>*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP form. Draw line through citation if not in conformance and not considered. Include a copy of this form with the next communication to applicant.</p>	



PTO/SB/08B (04-03)

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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (Use as many sheets as necessary)		<b>Complete if Known</b>	
		Application Number	09/610,637
		Filing Date	July 5, 2000
		First Named Inventor	Koichiro Tanaka
		Art Unit	2813
		Examiner Name	David S. Blum
Sheet 1	of 1	Attorney Docket Number	SEL 191

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
ASD ↓	1	KASAHARA, ET AL., "Laser Apparatus and Laser Annealing Method," U.S. Patent Application Serial No. 09/640,521, filed August 17, 2000, pp. 1-57, 19 pages of drawings.	
	2	KASAHARA, ET AL., Amendment to U.S. Patent Application Serial No. 09/640,521, mailed to the United States Patent and Trademark Office on December 2, 2002, pp. 1-5.	
	3	KASAHARA, ET AL., "Laser Apparatus and Laser Annealing Method," U.S. Patent Application Serial No. 09/640,521, filed August 17, 2000, official Filing Receipt.	
	4	KASAHARA, ET AL., "Laser Apparatus and Laser Annealing Method," U.S. Patent Application Serial No. 09/640,521, filed August 17, 2000, additional new claims added after filing.	

Examiner Signature		Date Considered	7/25/03
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<sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 120 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, Washington, DC 20231.

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